



Docket No.: 205890US99

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231



ATTORNEYS AT LAW

RE: Application Serial No.: 09/721,566
Applicants: Lyndee L. HILT, et al.
Filing Date: November 22, 2000
For: STRUCTURE AND METHOD FOR FABRICATING
SEMICONDUCTOR STRUCTURES AND
DEVICES UTILIZING THE FORMATION OF A
COMPLIANT SUBSTRATE FOR MATERIALS
USED TO FORM THE SAME
Group Art Unit: 2811
Examiner: HU, S.

RECEIVED
AUG 21 2002
TECHNOLOGY CENTER 2800

SIR:

Attached hereto for filing are the following papers:

**RESTRICTION RESPONSE; REQUEST FOR EXTENSION OF
TIME (THREE-MONTH)**

Our check in the amount of \$920.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

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